

<b>INFORMATION DISCLOSURE CITATION</b> <i>(Use several sheets if necessary)</i>				Docket Number (Optional) YPL-0037	Application Number 10/608,709		
				Applicant(s) Il Hwan Cho, et al.			
				Filing Date 6-27-2003	Group Art Unit 1625		
<b>U.S. PATENT DOCUMENTS</b>							
*EXAMINER INITIAL	REV	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
<i>Jr</i>		9,444,148	8-22-1993	Alewelt, et al.	528	196	11-19-1993
<b>U.S. PATENT APPLICATION PUBLICATIONS</b>							
*EXAMINER INITIAL	REV	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
<b>FOREIGN PATENT DOCUMENTS</b>							
REV	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATE	
						YES	NO
<b>OTHER DOCUMENTS</b> <i>(Including Author, Title, Date, Pertinent Pages, Etc.)</i>							
EXAMINER <i>[Signature]</i>				DATE CONSIDERED 8/11/05			
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